



AMAT Docket No. 2616 US/RTP/LE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Guangeai Xing, et al.

Serial No. 09/298,064

Filed: April 22, 1999

For: *APPARATUS AND METHOD FOR
EXPOSING A SUBSTRATE TO PLASMA
RADICALS*

Examiner: Zervigon, R.

Art Unit: 1763

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INFORMATION DISCLOSURE STATEMENT
WITH RULE 1.97(c) CERTIFICATION

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Pursuant to Rule 1.97, Applicants desire to make of record the references set forth on the attached form PTO 1449 which were cited in a written opinion dated February 26, 2001 of the corresponding PCT application. A copy of the PCT Written Opinion and copies of the cited references are submitted herewith.

It is hereby stated that each item of information contained in the attached form was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement. In the event any petition is needed for consideration of this Information Disclosure Statement, Applicant hereby so petitions. Please charge any additional fee due to Deposit Account 02-2666. A duplicate of the Fee Transmittal sheet is enclosed for charging purposes.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN

Date: 3/27/01

By: William F. Babbitt
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CERTIFICATE OF MAILING
I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on March 27, 2001.

Nedy Caldron 3/27/01
Nedy Caldron Date